CLAIMS:

1. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) configured to face a surface (102) to be cleaned, comprising

- a first suction body (11) and a second suction body (12) located at a distance relative to each other, wherein both the first suction body (11) and the second suction body (12) are configured to be operated to suck dust and dirt from the surface (102) to be cleaned, and wherein both the first suction body (11) and the second suction body (12) are connectable to a vacuum mechanism (20) configured to create underpressure at the position of the first suction body (11) and the second suction body (12); and characterized in that,

- a level setting mechanism (40) configured to put the first suction body (11) and the second suction body (12) at different overall levels relative to the surface (102) to be cleaned in a normal, operational orientation of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) on the surface (102);

wherein the level setting mechanism (40) comprises an element interconnecting the first suction body (11) and the second suction body (12), wherein the element is movably arranged in the nozzle arrangement (1, 2, 3, 4, 5, 6, 7).

2. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim 1, wherein the level setting mechanism (40) is configured to put the first suction body (11) at a lower overall level relative to the surface (102) to be cleaned and the second suction body (12) at a higher overall level relative to the surface (102) when the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) is subjected to a force related to a movement of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) with the first suction body (11) at a leading position and the second suction body (12) at a trailing position, and to put the second suction body (12) at a lower overall level relative to the surface (102) to be cleaned and the first suction body (11) at a higher overall level relative to the surface (102) when the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) is subjected to a force related to a movement of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) with the second suction body (12) at a leading position and the first suction body (11) at a trailing position.

~~3. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim 1 or 2, wherein the level setting mechanism (40) comprises an element interconnecting the first suction body (11) and the second suction body (12), which element is movably arranged in the nozzle arrangement (1, 2, 3, 4, 5, 6, 7).~~

~~4.~~3. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to ~~any of claims 1-3~~claim 1 or claim 2, wherein the level setting mechanism (40) comprises a carrier (41) of the first suction body (11) and the second suction body (12) that is tiltable about a tilting axis (42) in the nozzle arrangement (1, 2, 3, 4, 5, 6, 7), and wherein the first suction body (11) is connected to the carrier (41) at a location at one side of the tilting axis (42) and the second suction body (12) is connected to the carrier (41) at a location at the other side of the tilting axis (42) so that in the normal, operational orientation of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) on the surface (102) to be cleaned, the first suction body (11) and the second section body (12) move in opposite directions relative to the surface (102) as the carrier (41) tilts.

~~5.~~4. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to any of claims 1-~~4~~3, comprising a mopping assembly (30) configured to perform a mopping action on the surface (102) to be cleaned when the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) is moved along the surface (102), wherein the first suction body (11) and the second suction body (12) are located on either side of the mopping assembly (30).

~~6.~~5. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim ~~5~~4, wherein the mopping assembly (30) comprises a mop holder (31) configured to support a mopping element (32) configured to be wetted, wherein the mopping element (32) is attachable to and detachable from the mop holder (31).

~~7.~~6. Nozzle arrangement (2) according to claim ~~6~~5, wherein the first suction body (11), the second suction body (12) and at least a component of the mopping assembly (30) are jointly movable in the nozzle arrangement (2).

~~8.~~7. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim ~~6~~5 or ~~7~~6, wherein the mopping assembly (30) comprises a liquid tank (33) configured to contain liquid to be supplied to the mopping element (32) for wetting the mopping element (32).

~~9.~~8. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim ~~8~~7, wherein the mop holder (31) and the liquid tank (33) are integrated.

~~10.~~9. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to any of claims ~~5~~4-~~9~~8, wherein the mopping assembly (30) is removably arranged in the nozzle arrangement (1, 2, 3, 4, 5, 6, 7).

~~11.~~10. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim ~~10~~9, wherein the mopping assembly (30) is attachable to and detachable from a support (34) in the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) through a magnet connection, and wherein at least one of the mopping assembly (30) and the support (34) is equipped with at least one magnet (35).

~~12.~~11. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to any of claims 1-~~11~~10, comprising a suction enhancing mechanism (50) for at least partially closing at least one of the first suction body (11) and the second suction body (12) to one of the surface (102) to be cleaned and an internal air conduit (23, 24, 25) of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7).

~~13.~~12. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim ~~12~~11, wherein the suction enhancing mechanism (50) is configured to at least partially close the second suction body (12) while leaving the first suction body (11) open when the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) is subjected to a force related to a movement of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) with the first suction body (11) at a leading position and the second suction body (12) at a trailing position, and to at least partially close the first suction body (11) while leaving the second suction body (12) open when the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) is subjected to a force related to a movement of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) with the second suction body (12) at a leading position and the first suction body (11) at a trailing position.

~~14.~~13. Nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to claim ~~13~~12, wherein the suction enhancing mechanism (50) is arranged to be controlled by the level setting mechanism (40).

~~15.~~14. Cleaning appliance (100), comprising

- a nozzle arrangement (1, 2, 3, 4, 5, 6, 7) according to any of claims 1-14,
- a handle (101) that is connectable to the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) for allowing a user of the cleaning appliance (100) to control the position of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7) relative to a surface (102) to be cleaned, and
- a vacuum mechanism (20) configured to create underpressure at the position of the first suction body (11) and the second suction body (12) of the nozzle arrangement (1, 2, 3, 4, 5, 6, 7).